

Notice of References Cited	Application/Control No. 10/743,798	Applicant(s)/Patent Under Reexamination CHEN, Y.K.	
	Examiner Nathaniel C. Chukwurah	Art Unit 3721	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2003/0222116	12-2003	Chen et al.	227/139
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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